

DOCKET NO: 214144US8



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

NAOKI TSUKIJI ET AL. :

EXAMINER: SCHILLINGER, LAURA M.

SERIAL NO: 10/014,507 :

FILED: DECEMBER 14, 2001

GROUP ART UNIT: 2813

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT, AND  
SEMICONDUCTOR ELEMENT MANUFACTURED WITH THIS METHOD

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated September 8, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

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